



1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Reimer et al.

Serial No.: 09/505,580

Confirmation No.: 5947

Filed: February 16, 2000

For: Processing Apparatus
Having Integrated
Pumping System

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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Group Art Unit: 1763

Examiner: R. Bueker

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I hereby certify that this correspondence is being deposited on September 30, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.	
30 Sept 02 Date	<i>Andrew B. Steiner</i> Signature

RESPONSE TO REQUIREMENT FOR INFORMATION

In the Requirement for Information mailed July 31, 2002 the Examiner asked two specific questions related to an information disclosure statement filed by the Applicant July 25, 2002.

Specifically, the Examiner asked the following:

Is the pump that is described in the IDS filed July 25, 2002, capable of exhausting gas to atmospheric pressure?

In answer to the question, the pump that is described in the IDS is capable of exhausting gas to atmospheric pressure.

Does the pump that is described in the IDS filed July 25, 2002, include a controller for controlling the pressure in the vacuum chamber by changing the rotational speed of the pump?

In answer to the question, the pump that is described in the IDS does not include a controller for controlling the pressure in the vacuum chamber by changing the rotational speed of the pump.

The foregoing comments should satisfy the Request for Information mailed July 31, 2002.

Respectfully submitted,



William B. Patterson
Registration No. 34,102
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd., Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicant(s)